

Application/Control No.	Applicant(s)/Patent under Reexamination		
10/645,123	DETTINGER, RICHARD D		
Examiner	Art Unit		
Mellissa M. Chojnacki	2164	• .	

SEARCHED					
Class	Subclass	Date	Examiner		
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INTERFERENCE SEARCHED				
Examiner				
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Searched EAST, USPTO, JPO, EPO, IBM_TDB, PGPUB, Strategy enclosed.	9/21/2006	MMC		
Consulted Primary Examiner Sam Rimell regarding art and office action.	9/21/2006	ммс		
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